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Docket No.: 2328-062 PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): DHINDSA, Rajinder et al. : Confirmation No.8414

U.S. Patent Application No. 10/645,665 : Group Art Unit: 2821

Filed: August 22, 2003 : Examiner: TUNG X LE

For: MULTIPLE FREQUENCY PLASMA ETCH REACTOR

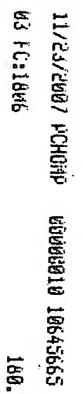
## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of the first Office Action on the merits, but before the mailing date of the Final Rejection or Notice of Allowance.



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A credit card authorization form in the amount of \$180.00 is attached. Any deficiency or overpayment should be charged or credited to Deposit Account No. 07-1337.

Respectfully submitted,

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